

In re Application of:

TOSHIMA, et al.

Serial No.: 10/052,534

Filed: January 23, 2002

For: Substrate Processing Apparatus and

SUBSTRATE PROCESSING METHOD

**CONFIRMATION NO. 3236** 

Art Unit: 1746

Examiner: Kornakov, Michail

Mail Stop: Amendment

Atty. Dckt: 033082M115

## RESPONSE UNDER 37 C.F.R. 1.111

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

This is in response to the Office Action mailed April 4, 2007, to which the time for response was set to expire July 4, 2007. A Petition for a Three-Month Extension of Time and the requisite fee are submitted herewith to extend the due date to October 4, 2007. Claims 1-19 and 35 were rejected and claims 10-19 were withdrawn. Reconsideration and entry of the following amendment(s) are respectfully requested.

Amendment to the Claims begins on page 2 of this paper. Remarks begin on page 9 of this paper.